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w/ Amdt. E
Jherlepa
Patent 4-18-02



Attorney's Docket No.: 042390.P4220

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Re Application of:

Bohr, Mark T.

U.S. Serial No: 09/002,178

Filed: December 31, 1997

For: WAFER PASSIVATION
STRUCTURE AND METHOD OF
FABRICATION

Examiner: Guerrero, Maria F.

Art Unit: 2822

Assistant Commissioner for Patents
Washington, D.C. 20231

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TECHNOLOGY CENTER 2800

AMENDMENT AND RESPONSE

Dear Sir:

This is in response to the Office Action mailed November 29, 2001. Applicant respectfully requests the Examiner to enter the following amendments and consider the following remarks.

FIRST CLASS CERTIFICATE OF MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage in an envelope addressed to the Assistant Commissioner of Patents, Washington, D.C. 20231

on March 28, 2002

Date of Deposit

Teresa Edwards

Name of Person Mailing Correspondence

Teresa Edwards
Signatur

March 28, 2002
Date